



Docket No.: 1082.1042

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hitoshi YAMADA, et al.

Serial No. 10/076,333

Group Art Unit: 2875

Confirmation No. 2004

Filed: February 19, 2002

Examiner: Dalei DONG

For: GAS DISCHARGE TUBE AND METHOD FOR FORMING ELECTRON EMISSION
LAYER IN GAS DISCHARGE TUBE

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed October 24, 2003, and having a period for response set to expire on January 24, 2004.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.

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